

**Search Notes**

Application/Control No.

10/523,227

Examiner

Jafar Parsa

Applicant(s)/Patent under  
Reexamination

NAPPA ET AL.

Art Unit

1621

**SEARCHED**

| Class | Subclass              | Date      | Examiner |
|-------|-----------------------|-----------|----------|
| 570   | 169, 168,<br>166, 165 | 1/22/2006 | JP       |
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**INTERFERENCE SEARCHED**

| Class | Subclass | Date      | Examiner |
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| 570   | 169, 168 | 1/22/2006 | JP       |
| 570   | 166, 165 | 1/22/2006 | jp       |
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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

|                      | DATE      | EXMR |
|----------------------|-----------|------|
| East                 | 1/22/2006 | JP   |
| Inventor name search | 1/22/2006 | JP   |
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